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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

Dong-Jae Shin et al.

SERIAL NO.:

10/691,392

EXAMINER: Phillip Nguyen

DATE FILED:

October 22, 2003

ART UNIT: 2828

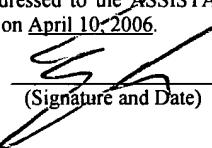
FOR:

METHOD FOR MAINTAINING MODE-LOCKED STATE OF
FABRY-PEROT LASER IRRESPECTIVE OF TEMPERATURE
CHANGE

CERTIFICATE OF MAILING UNDER 37 CFR §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, P.O. BOX 1450 ALEXANDRIA, VA 22313 on April 10, 2006.

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(Name of depositor)


(Signature and Date)

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313

Sir:

INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's and Applicant's representatives' Duty of Disclosure under 37 CFR § 1.56, and pursuant to 37 CFR §1.97(d) and MPEP 717.05(b), Applicant(s) submit herewith documentary information for consideration by the Examiner. Information herein cited is only set forth in fulfillment of Applicant's duty of candor in disclosing all information brought to his attention, and is not an admission that it can be used adversely. The publications forwarded herewith are listed on the enclosed Form PTO-1449. Applicant(s) request that the Examiner, upon reviewing the enclosed materials, initial the enclosed form and return a copy thereof in accordance with the instructions on the form.

Applicant further note that each item of information contained in the enclosed Form was first cited from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the statement.

Enclosed please find copies of 1 Publication listed on the attached Form PTO-1449. A fee of \$180.00 as set forth in 37 CFR 1.17(p) is enclosed herein.

Respectfully submitted,


Steve S. Cha
Attorney for Applicants
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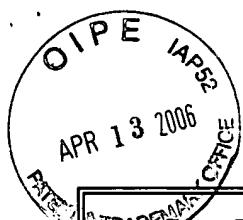
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Date: April 10, 2006



Form PTO-1449 IRSY. 7.801 U.S. Department of Commerce Patent and Trademark Office		ATTORNEY DOCKET NO. 5000-1-467
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LIST OF DOCUMENTARY INFORMATION CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Dong-Jae Shin et al.
		FILING DATE October 22, 2003
		GROUP 2828

U.S. PATENT DOCUMENTS

EXAMINE R INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AA	CHANG HEE LEE et al.; Patent Application Publication No: US 2001/0004290 A1; Publication Date: June 21, 2001; "Low-Cost WDM Source with an Incoherent Light Injected Fabry-Perot Laser Diode;"	
EXAMINER:	DATE CONSIDERED:	
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		